



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Small et al.
Title: Catalytic Composition for Chemical-Mechanical Polishing, Method of Using Same, and Substrate Treated with Same
Serial No.: 10/619,708 Filed: July 14, 2003
Examiner: Unknown Group Art Unit: 3723
Docket No.: CHEM.004US2 Conf. No.: 7752

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on 4/23/04

Gileen Baur
Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application.

This application has a filing date after June 30, 2003. Copies of the U.S. Patents listed on the accompanying Form PTO-1449 are not enclosed.

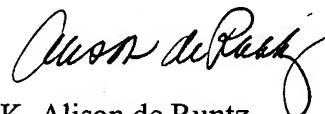
Listing of these documents shall not be construed as:

1. an admission that any of these documents is necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or

3. an admission that information in any of these documents is, or is considered to be, material to patentability as defined in § 1.56(b).

This information disclosure statement is submitted under 37 C.F.R. § 1.97(b) and consequently no fee should be required. The Commissioner is authorized, however, to charge any fee that may be required, or to credit any overpayment, against Deposit Account No. 502664. This form is being submitted in duplicate.

Respectfully submitted,



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APR 26 2004

Sheet 1 of 1

U.S. Department of Commerce, Patent and Trademark INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Atty. Docket No.			Application No.			
		CHEM.004US2			10/619,708			
		Applicant(s)			Conf. No.			
(Use several sheets if necessary)		Small et al.			7752			
		Filing Date			Group			
		July 14, 2003			3723			
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	1	6,541,384	4/1/03	Sun et al.				
	2	6,468,428	10/22/02	Nishii et al.				
U.S. Published Patent Application Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
Examiner		Date Considered						
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>								